TECHNICAL ARTICLE

Crystal orientation measurements using SEM–EBSD under unconventional conditions

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Electron backscatter diffraction (EBSD) is a micro-analytical technique typically attached to a scanning electron microscope (SEM). The vast majority of EBSD measurements is applied to planar and polished surfaces of polycrystalline bulk specimen. In this paper, we present examples of using EBSD and energy-dispersive X-ray spectroscopy (EDX) to analyze specimens that are not flat, not planar, or not bulk – but pillars, needles, and rods. The benefits of low vacuum SEM operation to reduced drift problems are displayed. It is further demonstrated that small and thin specimens enhance the attainable spatial resolution for orientation mapping (by EBSD or transmission Kikuchi diffraction) as well as for element mapping (by EDX). © 2015 International Centre for Diffraction Data. [doi:10.1017/S0885715615000263]

I. INTRODUCTION

Electron backscatter diffraction (EBSD) is a micro-analytical technique typically attached to a scanning electron microscope (SEM). It provides information on the crystallographic structure and phase, crystal orientation, and/or lattice strain from volumes in the size of 10–100 nm
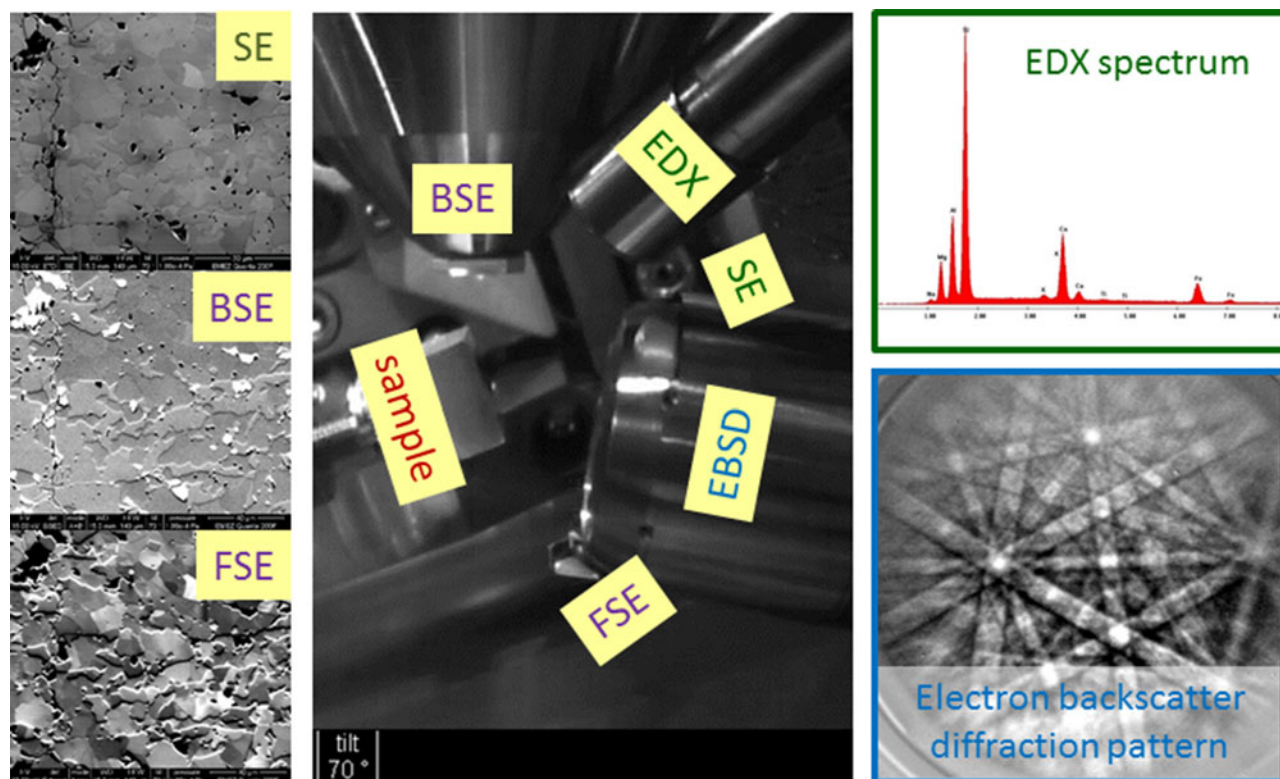

Figure 1. (Color online) Setup of an analytical SEM for simultaneous detection of SE, BSE, FSE imaging signals, EDX spectra, and EBSD patterns. Images of an interfingering contact between magnetite (brighter gray, bottom left in the BSE image) and hematite (darker gray, upper right in the BSE image) illustrate topographic, compositional, and orientation contrast (sample courtesy of Heinrich Siemes, Aachen).

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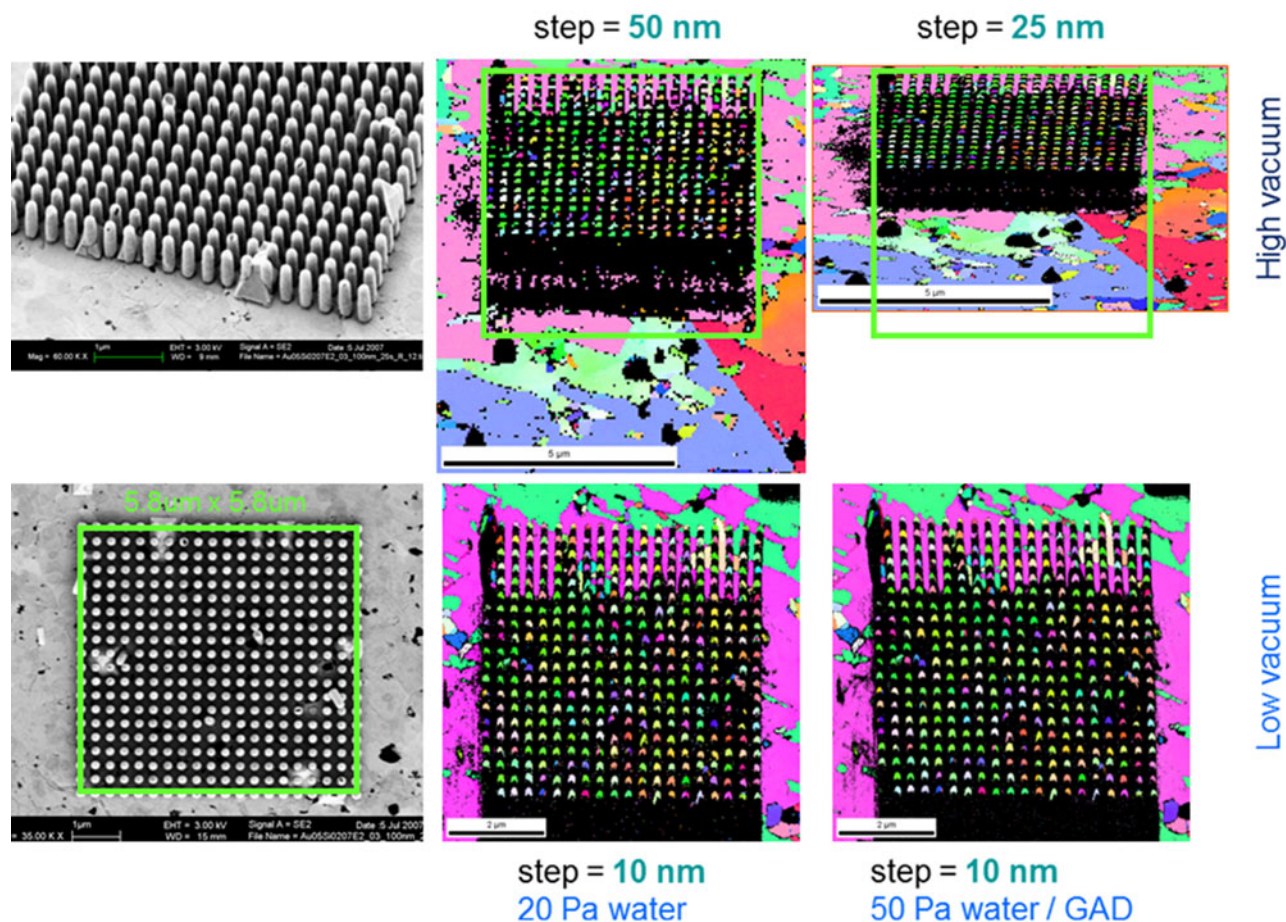karsten.kunze@scopem.ethz.ch

Figure 2.   (Color online) Regular array of Gold pillars mapped in conventional EBSD geometry (substrate tilted by 70°), with major drift problems under high vacuum in the SEM (top), and negligible drift under low vacuum (Buzzi, 2009).

in diameter (Zaefferer, 2007). Automated sequential acquisition enables microstructural mapping, also called orientation imaging microscopy (OIM) (Adams *et al.*, 1993).

As such it allows quantitative characterization and interpretation of the diverse multi-modal imaging from secondary electron (SE), backscatter electron (BSE) or forescatter electron (FSE) detector signals, giving rise to topographic,
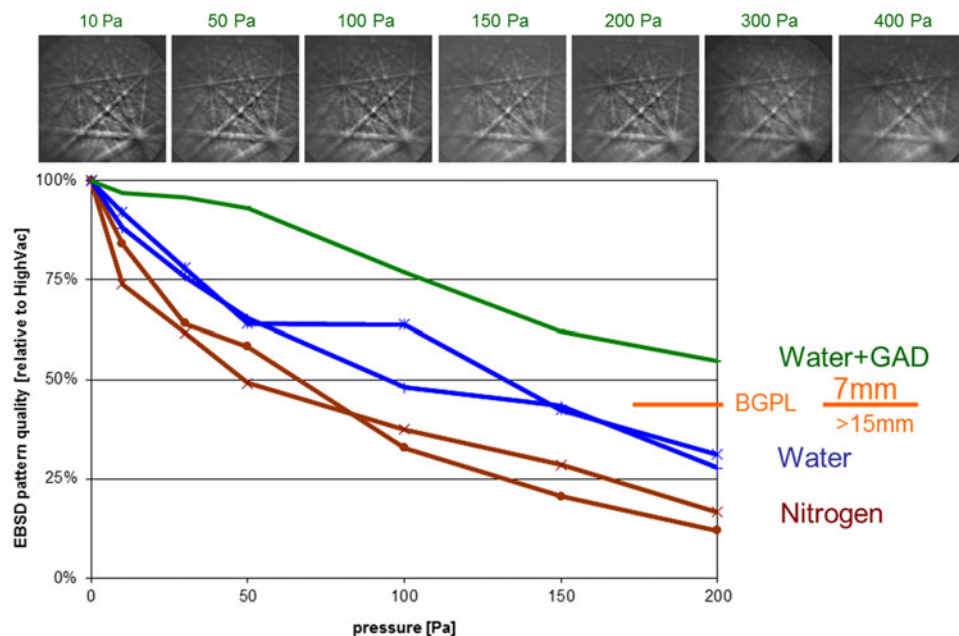

Figure 3.   (Color online) Variation of the EBSD pattern quality with increasing SEM chamber pressure. Sequence of patterns from calcite (dynamic background corrected, top row); relative pattern quality (parameter IQ of OIM software, EDAX, USA) vs. chamber pressure.
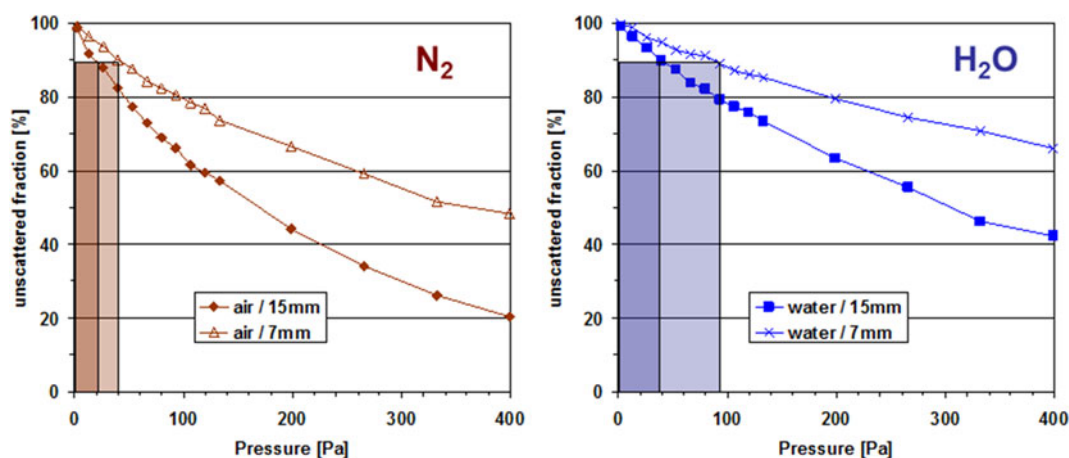
Figure 4. (Color online) Simulation of reduction of unscattered fraction of the electron beam with increasing SEM chamber pressure, facilitated by freeware Casino version 2.42 (Drouin *et al.*, 2007). The amount scattering is predicted to reduce for shorter working distance (BGPL), water preferred to air, and lower pressure.
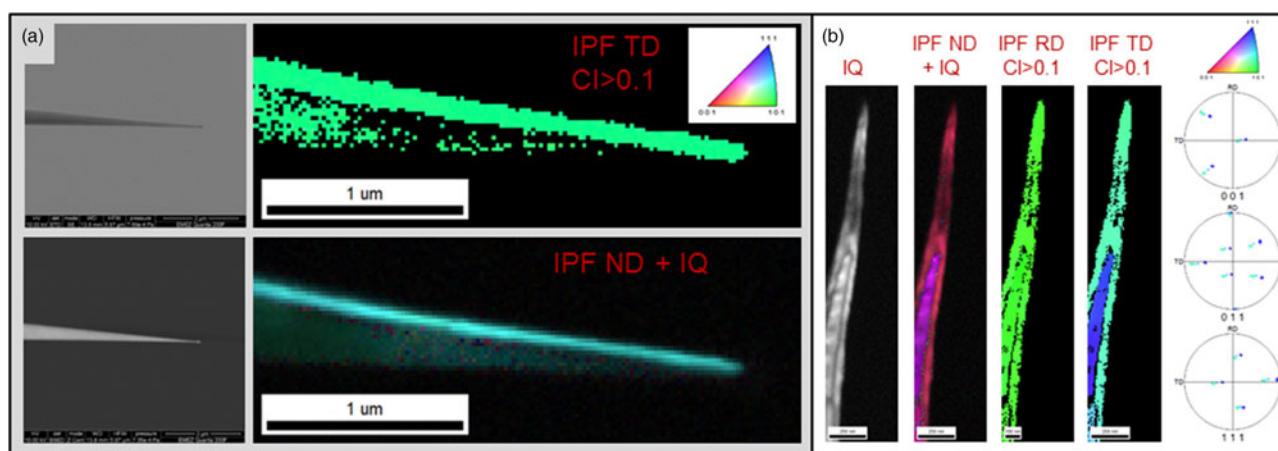

Figure 5. (Color online) Sharp tips of tungsten needles are analyzed for their crystal orientation. (a) In horizontal position, only a narrow strip is accessible to high-quality data. (b) In downwards tilted position, the needle is accessible in its full extent, and the mapping allows us to separate grain boundaries between raster steps of 10 nm (sample courtesy of Urs Ramsperger, Zürich).

compositional, and orientation contrast (Figure 1; Payton and Nolze, 2013). It is applied complementary to energy-dispersive X-ray spectroscopy (EDX or EDS), which provides information on elemental composition, typically at the micrometer scale. In that sense, EDX can be seen as the micro-analytical equivalent to X-ray fluorescence, whereas EBSD stands as the micro-analytical pendant to X-ray diffraction.

The vast majority of EBSD measurements is applied to planar and polished surfaces of polycrystalline bulk specimen. In this paper, we present examples of using EBSD and EDX to analyze specimens that are not flat, not planar, or not bulk – but pillars, needles, and rods.

II. PILLARS: THE BENEFITS OF LOW VACUUM

Sub-micrometer-sized Gold pillars (Buzzi, 2009) deliver good quality EBSD patterns from their top head area, while no indexable patterns are available from the interspace between pillars in a dense array (Figure 2). Despite of being electrically well-conductive, mapping of such arrays is destructed by major drift problems because of local charging under high vacuum in the SEM chamber. Drift is nearly absent in

mappings under low vacuum (water vapor), and stability is further improved by the snorkel attachment of the gaseous analytical detector (GAD) reducing the beam gas path length (BGPL) between bottom pressure-limiting aperture and sample. Grain boundaries are possible to separate between raster steps as small as 10 nm (Kunze *et al.*, 2008).

Any gaseous medium in the SEM vacuum chamber causes some scattering of the incident and diffracted beams, and thus should be avoided as much as possible. The amount of reduction in EBSD pattern quality can be minimized by shorter BGPL, lower pressure, and using water vapor instead of air, as demonstrated by the experimental data (Figure 3) as well as by Monto-Carlo simulations (Drouin *et al.*, 2007) of unscattered beam fraction (Figure 4).

III. NEEDLES: FINDING THE OPTIMUM MEASUREMENT GEOMETRY

Instead of analyzing pillars from the top, they may be mounted with their axis perpendicular to the electron beam (Camus *et al.*, 2011). Sharply etched tungsten tips were analyzed for the crystal orientation at the very front tip. With the needle
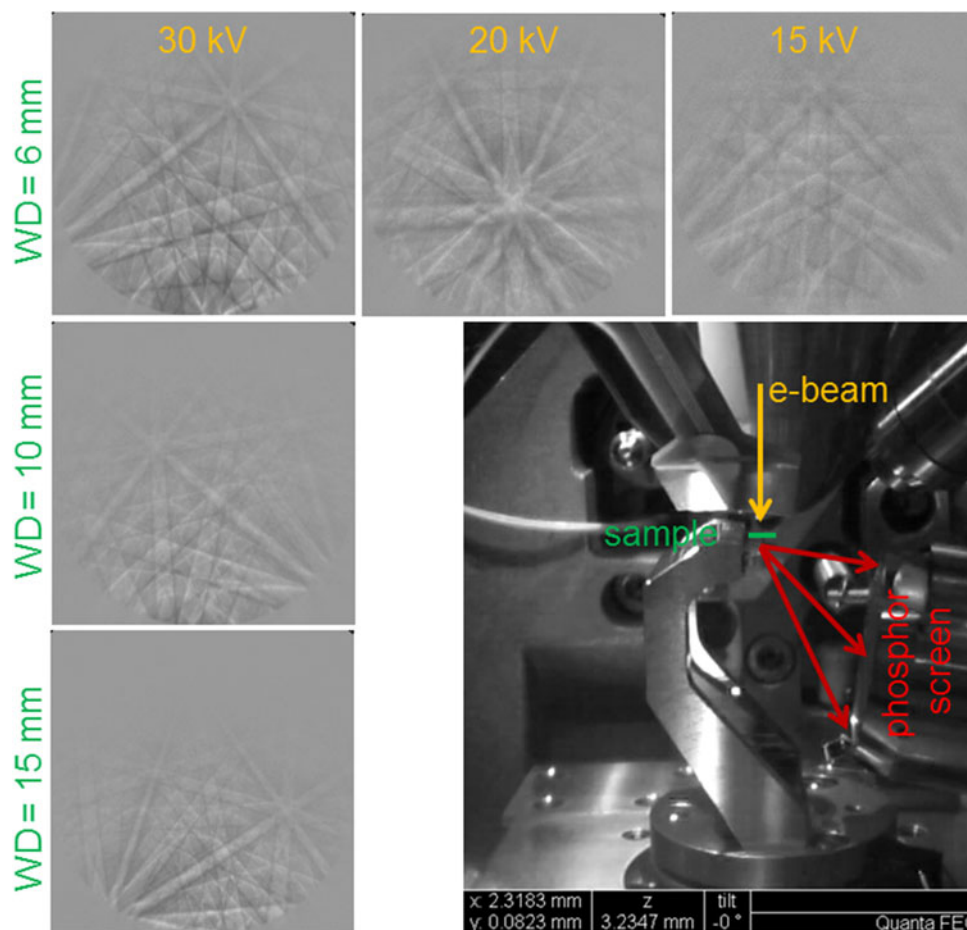
Figure 6. (Color online) Setup of a modified EBSD system to collect TKD patterns. Variation of (copper) pattern illumination with working distance (WD) and accelerating voltage (in kV).

directed horizontally, a narrow strip on the conical surface satisfies about the 70° tilt, which gives rise to high-quality EBSD patterns (Figure 5). Remarkably, reliable and valid indexations were also obtained from thinker parts of the cone.

The full extent of the needle is available to orientation mapping, if the needle is mounted dipping 55° downwards to the EBSD detector. The grain boundary (of about 20° misorientation angle) is resolved in mappings with raster steps of 10 nm.

IV. RODS: USING THE TRANSMISSION KIKUCHI DIFFRACTION (TKD) TECHNIQUE

It was proposed recently (Keller and Geiss, 2012; Trimby, 2012), how to covert the EBSD system from backscatter to transmission geometry. With a suitable holder (here the commercially available holder for scanning transmission electron microscopy) for thin specimens, the EBSD detector can collect TKD patterns (Figure 6) from electron transparent foils conventionally prepared for transmission electron microscopy (TEM) (e.g. Kunze *et al.*, 2013). The phosphor screen is optimally illuminated for high accelerating voltage and short working distance.

Fe–Co rods on sub-hundred nanometer size were sparsely dispersed on a carbon-foil TEM grid, and crystal orientation mapping was facilitated. A rough statistical overview is obtained, when the maps are post-processed for grain size and grain shape, and the color legend is adopted to display the crystal direction parallel to the long grain axis (Figure 7). This approach verifies ⟨111⟩ to be preferred along the rod long axis.

Individual Fe–Co nano-rods were mounted at the front tip of Si-cantilevers for orientation mapping (by TKD) as well as element mapping (by EDX); see Figure 8. The nano-rods contain subgrains with relevant misorientation angles, but are preferred aligned along ⟨111⟩. Since the X-ray emission volume is kept small for such thin rods, the element maps reveal some remarkable spatial resolution well below 100 nm, and a seed layer (Pt) of 10–20 nm thickness is detected. Care must be taken when interpreting the abundant elements, as the maps also contain stray signals from the cantilever (Si), sample holder (Al), and other parts in the sample surroundings.

V. DISCUSSION AND CONCLUSIONS

The presented examples demonstrate application fields of EBSD and EDX as micro- and nano-analytical tools for characterization of samples beyond the conventionally prepared flat, polished bulk specimens. It is shown that:

- Charging related drift problems may occur even on electrically well-conducting materials and are largely suppressed by introducing a water vapor in a low vacuum environment.
- Needles and pillars are best analyzed when placed in downwards tilted position.
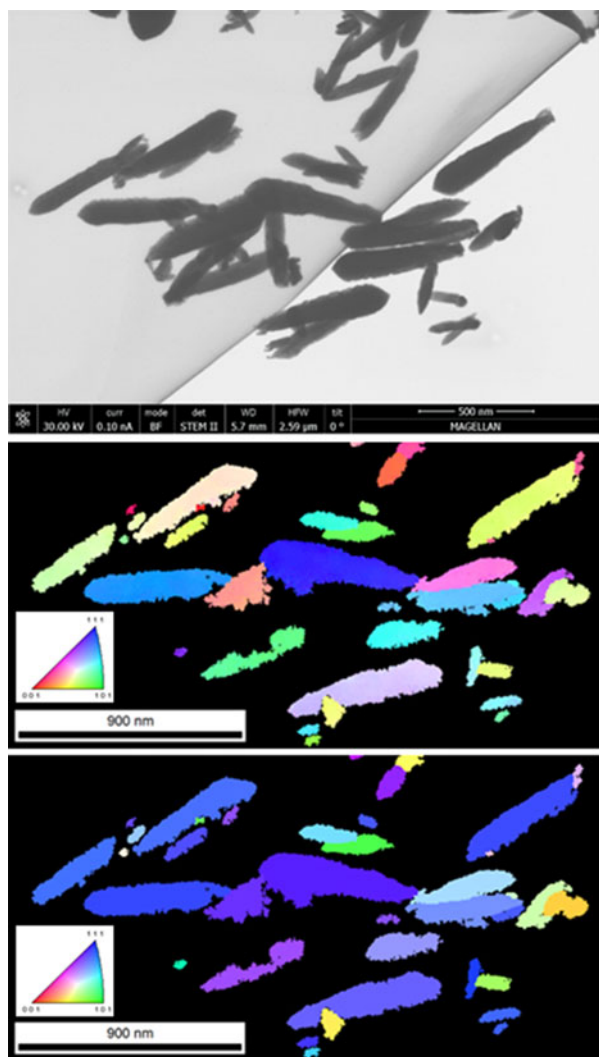- Nano-rods and other thin objects (TEM foils or lamellae) are efficiently analyzed by TKD and EDX in the SEM, both

Figure 7. (Color online) Fe–Co nano-rods dispersed on a carbon foil, imaged by STEM-BF (top) and analyzed by TKD mapping. Instead of using a conventional color code with respect to a fixed reference direction (middle), a coloring with respect to the individual grain long axis reveals their preferred ⟨111⟩ orientation (bottom) (sample courtesy of Ye Tao, Zürich).

with higher spatial resolution than commonly reached on bulk specimen.

ACKNOWLEDGMENTS

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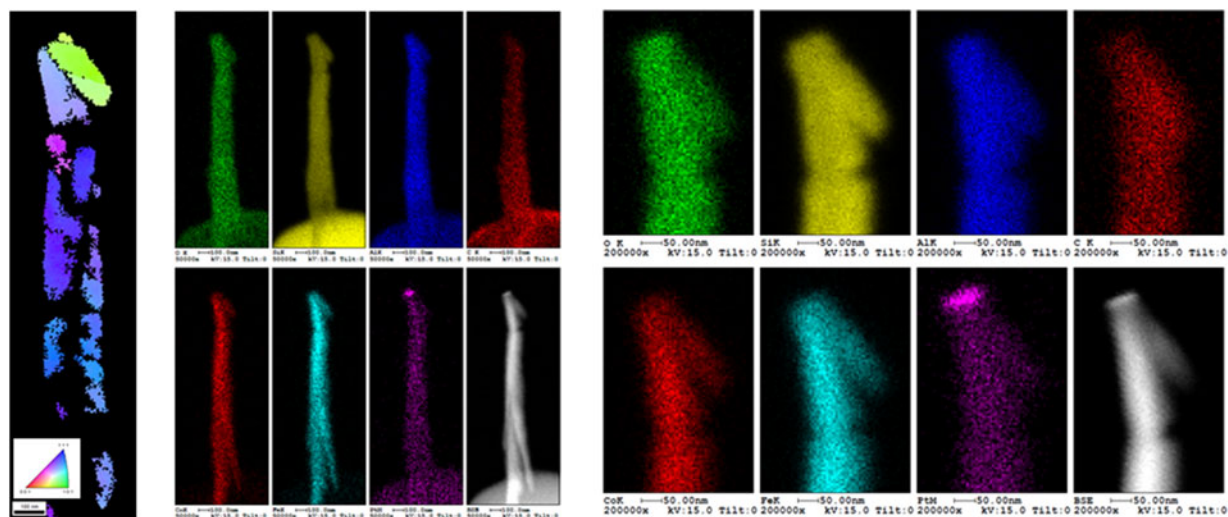
Figure 8. (Color online) Orientation map by TKD (left) and element maps by EDX (center and right) of Fe–Co nano-rods acquired in transmission geometry (FEG–SEM FEI Quanta200F at 15 kV). Acceptable mapping of the major elements (Fe and Co), but stray signals excite additional elements (O, Si, Al, and C) as well. Clear detection of the seed layer (Pt) at the top of the rod (sample courtesy of Ye Tao, Zürich).